Agilent Ref: 10030712-1 United States Application Serial No. 10/722,950

<u>AMENDMENTS</u>

In The Claims:

Please cancel Claims 2-11, 14, 15, 25, 26, 40-52, and 56.

- 1. (Previously Presented) A method for treating a backing element comprising a gasket for forming a sealed array assay chamber when joined to a microarray substrate, said method comprising at least one of: (1) depositing a component on said gasket, (2) extracting a component from said gasket, (3) surface modifying said gasket, to treat said gasket.
- 2.-15. (Canceled)
- 16. (Previously Presented) The method of Claim 1, wherein said method comprises surface modifying said gasket.
- 17. (Previously Presented) The method of Claim 16, wherein said surface modification comprises contacting said gasket with a plasma.
- 18. (Previously Presented) The method of Claim 17, wherein said plasma is produced from a gas selected from the group consisting of nitrogen, air, argon, oxygen, nitrous oxide, helium, water vapor, carbon dioxide, methane, and combinations thereof.
- 19.-26. (Canceled)
- 27. (Previously Presented) The method of Claim 1, wherein said treating comprises increasing the hydrophilicity of said gasket.
- 28. (Currently Amended) The method of Claim 1, wherein said treating <u>allows</u> provides a seal about said gasket to form a seal.

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29. (Previously Presented) The method of Claim 1, wherein said treating comprises sequentially contacting said gasket with at least two of: plasma, UV with O₂ and a solvent.

30.-52. (Canceled)

- 53. (Previously Presented) A method for treating a backing element comprising a gasket for forming a sealed array assay chamber when joined to a microarray substrate, said method comprising surface modifying said gasket to treat said gasket.
- 54. (Previously Presented) The method of Claim 53, wherein said surface modification comprises contacting said gasket with a plasma.
- 55. (Previously Presented) The method of Claim 54, wherein said plasma is produced from a gas selected from the group consisting of nitrogen, air, argon, oxygen, nitrous oxide, helium, water vapor, carbon dioxide, methane, and combinations thereof.
- 56. (Canceled)

Please add new claims 57-62.

57. (New) A method for treating a backing element comprising a gasket, wherein sald method comprises:

surface modifying said gasket to treat said gasket; and producing a sealed array assay chamber comprising said gasket about at least one array of a microarray assembly.

58. (New) The method of Claim 57, wherein said surface modification comprises contacting said gasket with a plasma.

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- 59. (New) The method of Claim 58, wherein said plasma is produced from a gas selected from the group consisting of nitrogen, air, argon, oxygen, nitrous oxide, helium, water vapor, carbon dioxide, methane, and combinations thereof.
- 60. (New) The method of Claim 57, wherein said treating comprises increasing the hydrophilicity of said gasket.
- 61. (New) The method of Claim 57, wherein said treating allows said gasket to form a seal.
- 62. (New) The method of Claim 57, wherein said treating comprises sequentially contacting said gasket with at least two of: plasma, UV with O_2 and a solvent.